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22141 U.S. PTO
10/678317



Atty. Docket No.: M-15210 US

October 3, 2003

Mail Stop Patent Application
Director of USPTO
P.O. Box 1450
Alexandria, VA 22313-1450

Enclosed herewith for filing is a patent application, as follows:

Inventor(s): Yi Ding
Title: Nonvolatile Memory Fabrication Methods Comprising Lateral Recessing of Dielectric Sidewalls At Substrate Isolation Regions
X Return Receipt Postcard
X This Transmittal Letter (in duplicate)
8 page(s) Specification
3 page(s) Claims
1 page Abstract
8 Sheet(s) of Drawings
2 page(s) Declaration For Patent Application and Power of Attorney
1 page Recordation Form Cover Sheet (in duplicate)
1 page Assignment

CLAIMS AS FILED

For	Number Filed			Number Extra		Rate		Basic Fee
Total Claims	13	-20	=	0	X	\$18.00	=	\$ 770.00 0.00
Independent Claims	1	-3	=	0	X	\$86.00	=	\$ 0.00
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/>	Fee for Request for Extension of Time							\$

Please make the following charges to Deposit Account No. 50-2257:

- ☒ Total fee for filing the patent application in the amount of \$ 770.00
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-2257.

EXPRESS MAIL LABEL NO:

EL 968 134 552 US

Respectfully submitted,

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